

Annealsys signed distribution agreement with Leighton Electronics Inc. (LEI)

Montpellier, France, May 16, 2017

Annealsys is pleased to announce a Distributor agreement with **Leighton Electronics Inc. (LEI)** for the sales and service of their sheet resistance and carrier mobility systems in South Europe (France, Spain, Portugal, Italy, Belgium and Switzerland).

Founded in 1963, Leighton Electronics Inc. (LEI) is a true pioneer in the design and development of contactless metrology instrumentation with more than 400 resistivity systems and more than 40 mobility systems in the field.

LEI offers a family of reliable and easy to operate non-destructive bulk resistivity and sheet resistance measurement systems. These instruments are capable of characterizing a variety of structures for compound semiconductor and silicon devices, solar cells and flat panel displays.

LEI also offers a line of non-destructive mobility measurement systems using microwave technique. LEI engineered design allows for fast and precise output of carrier mobility, carrier density and sheet resistance.

The association of Leighton Electronics Inc. (LEI) expertise in sheet resistivity and carrier mobility measurement with Annealsys experience and leading market position in RTP and DLI systems provide consistent process development and characterization solutions to our South Europe customers.

About Leighton:

Established in 1963, LEI has developed into an industry leader manufacturing non-destructive testing equipment used in the semiconductor field, particularly the compound semiconductor market. Additional product applications include photovoltaic, flat panel display, silicon and LED metrologies. LEI designs and manufactures multiple lines of non-destructive, precision instruments that provide sheet resistance, conductivity and mobility measurements.

www.leighton.com

About Annealsys:

Annealsys is a leading manufacturer of RTP and DLI-CVD / DLI-ALD systems for research and niche production applications in the fields of silicon and compound semiconductors, nanotechnologies, MEMS, solar cells, glass, etc. Annealsys has developed a range of RTP systems with high temperature and high vacuum capabilities and some unique features like the fast cooling system. Direct Liquid Injection (DLI) CVD and ALD systems offer the highest process versatility for development of new materials. Visit Annealsys web site at www.annealsys.com